

High-performance monolayer MoS₂ field-effect transistors and photodetectors on SiO₂ gate dielectric passivated with cyclic olefin copolymer

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Trap states of the semiconductor/gate dielectric interface give rise to a pronounced subthreshold behavior in field-effect transistors (FETs) diminishing and masking intrinsic properties of 2D materials. To reduce the well-known detrimental effect of SiO₂ surface traps, this work spin-coated an ultrathin (≈ 5 nm) cyclic olefin copolymer (COC) layer onto the oxide and this hydrophobic layer acts as a surface passivator. The chemical resistance of COC allows to fabricate monolayer MoS₂ FETs on SiO₂ by standard cleanroom processes. This way, the interface trap density is lowered and stabilized almost fivefold, to around $5 \times 10^{11} \text{ cm}^{-2} \text{ eV}^{-1}$, which enables low-voltage FETs even on 300 nm thick SiO₂. In addition to this superior electrical performance, the photoresponsivity of the MoS₂ devices on passivated oxide is also enhanced by four orders of magnitude compared to nonpassivated MoS₂ FETs. Under these conditions, negative photoconductivity and a photoresponsivity of $3 \times 10^7 \text{ A W}^{-1}$ is observed which is a new highest value for MoS₂. These findings indicate that the ultrathin COC passivation of the gate dielectric enables to probe exciting properties of the atomically thin 2D semiconductor, rather than interface trap dominated effects.

References

[1] S.B. Kalkan, E. Najafidehaghani et al., *Adv. Optical Mater.* 11 (2023) 2201653.

Figures

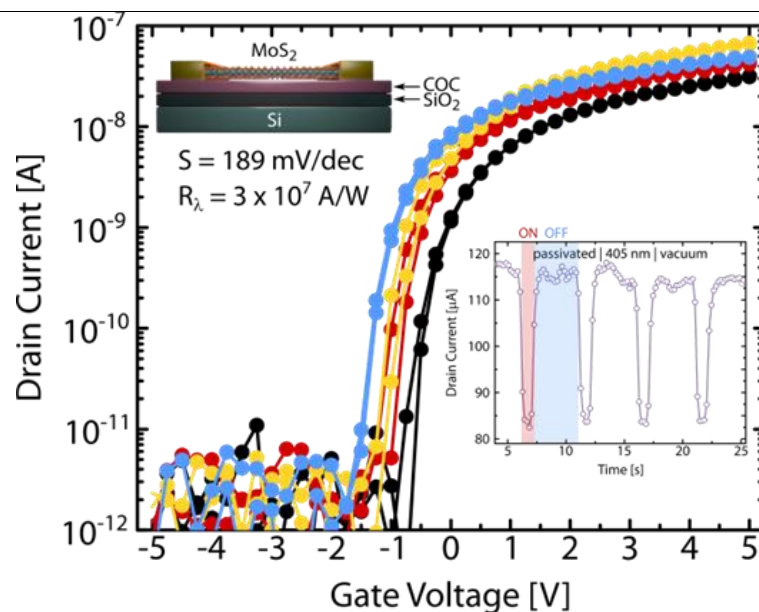


Figure 1: Performance of monolayer MoS₂ based electronic and optoelectronic devices on SiO₂ gate dielectric passivated with cyclic olefin copolymer.